



TFCW 1742

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT		Docket Number 52433/797	
Application Number 10/535,346	Filing Date October 03, 2005	Examiner Not Yet Assigned	Art Unit 1742
Title METHOD OF MANUFACTURING METAL PRODUCT HAVING NANO-CRYSTALLIZED SURFACE LAYER		Applicant(s) Tadashi ISHIKAWA et al.	

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on:

Date: August 2, 2006

Signature: John J. Kelly, Jr.

1. In accordance with the continuing duty of disclosure under 37 C.F.R. § 1.56 and in conformance with the procedures of 37 C.F.R. §§ 1.97 and 1.98 and M.P.E.P. § 609, attorney(s) for Applicant(s) hereby bring the reference(s) listed on the attached modified PTO Form No. 1449 to the attention of the Examiner. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.
2. A copy of each patent, publication or other information listed on the modified PTO form 1449 is enclosed, except as otherwise indicated.
3. Pursuant to 37 C.F.R. § 1.97(c) and § 1.97(e), Applicants' attorney certifies that each item of information contained in this Information Disclosure Statement was first cited in a communication dated May 26, 2006 from a foreign patent office in a counterpart foreign (European) patent application not more than three months prior to the filing of this Supplemental Information Disclosure Statement.
4. It is believed that no fees are due in connection with this Supplemental Information Disclosure Statement. However, should any fees be due, the Commissioner is authorized to charge Deposit Account No. 11-0600 for such fees. A duplicate copy of this communication is enclosed for charging purposes.

Dated: August 2, 2006

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449	DOCKET NO. 52433/797	SERIAL NO. 10/535,346
	APPLICANT	
	Tadashi ISHIKAWA et al.	
	FILING DATE October 03, 2005	GROUP 1742

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE	NAME	CLASS	SUBCLASS	FILING DATE

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
	WO 02/10462 A1	February 07, 2002	PCT			Abstract	

OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.		
	Tao N.R. et al: "Surface Nanocrystallization of Iron Induced by Ultrasonic Shot Peening", June 04, 1999, Nanostructured Materials, Vol. 11, no. 4, pages 433-140.		

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	